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LISTING OF THE CLAIMS

The following listing of claims will replace all prior versions and listings of claims in the application.

1. (Previously Amended) An integrated burn-in test method for testing a multi-chip package, comprising:

uploading an integrated burn-in test program to burn-in equipment for testing the multichip package having multiple kinds of semiconductor devices; and

conducting a test on each of the multiple kinds of semiconductor devices using the integrated burn-in test program; wherein,

the multiple kinds of semiconductor devices include at least two of a non-volatile memory, a SRAM, and a DRAM, and the integrated burn-in test program is adapted to test the non-volatile memory, the SRAM, and the DRAM.

- 2. (Canceled)
- 3. (Canceled)
- 4. (Original) The method of claim 1, wherein the multi-chip package performs a memory function.

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5. (Previously Presented) The method of claim 1, wherein the test is conducted for

each of the semiconductor devices at a different temperature.

6. (Previously Presented) The method of claim 1, wherein the multi-chip package is

loaded on a burn-in board and the burn-in board is loaded in a chamber of burn-in equipment.

7. (Original) The method of claim 1, wherein the multi-chip package is in the form

of a TBGA (thin ball grid array).

8. (Previously Presented) The method of claim 1, wherein the integrated burn-in test

program uses a multiplexer selection function for applying a desired test condition during testing

of each of the semiconductor devices.

9. (Original) The method of claim 1, wherein the integrated burn-in test program has

an I/O masking function for blocking some I/O terminals.

10. (Previously Presented) The method of claim 1, wherein the integrated burn-in test

program has a function of setting a burn-in temperature condition for each of the semiconductor

devices.

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11. (Previously Presented) The method of claim 6, wherein after loading the multi-

chip package on the burn-in board to the chamber of the burn-in equipment, a contact test is

conducted to examine whether an electrical connection of the burn-in board is correct.

12. (Original) The method claimed in claim 1, wherein the burn-in test is a

monitoring burn-in test.

13. (Original) The method of claim 1, wherein the integrated burn-in test program

requires only one time bin sorting based on the burn-in test result.

14. (Previously Amended) An integrated burn-in test method for testing a multi-chip

package, comprising:

uploading an integrated burn-in test program to test the multi-chip package having

multiple kinds of semiconductor devices to burn-in equipment, the multiple kinds of

semiconductor devices include at least two of a non-volatile memory, a SRAM, and a DRAM;

conducting a contact test for a burn-in board to examine an electrical connection;

conducting a burn-in test for each of the semiconductor devices using a multiplex

selection function of the integrated burn-in test program loaded to the burn-in equipment, the

burn-in test for each of the semiconductor devices is performed sequentially and the integrated

burn-in test program controls the chamber temperature according to a test temperature for each

of the semiconductor devices;

ending the burn-in test; and

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bin sorting the multi-chip package based on the burn-in test result.

- 15. (Canceled)
- 16. (Previously Presented) The method of claim 14, wherein each of the semiconductor devices performs a memory function.
- 17. (Original) The method of claim 14, wherein the integrated burn-in test program has an I/O masking function for blocking some I/O terminals.
- 18. (Original) The method of claim 17, wherein each semiconductor device of the multi-chip package has a different number of I/O terminal pins.
- 19. (Original) The method of claim 14, wherein the multi-chip package is in the form of a TBGA (thin ball grid array).
- 20. (Original) The method of claim 14, wherein the burn-in test is a monitoring burn-in test.
- 21. (Previously Amended) An integrated burn-in test method for testing a multi-chip package, comprising:

providing the multi-chip package formed of multiple kinds of semiconductor devices; and

testing the multi-chip package with an integrated burn-in test program, wherein the burnin test program is adapted to test each of the semiconductor devices; wherein,

the multiple kinds of semiconductor devices include at least two of a non-volatile memory, a SRAM, and a DRAM, and the integrated burn-in test program is adapted to test the non-volatile memory, the SRAM, and the DRAM.

- 22. (Previously Presented) The method of claim 21, wherein the testing includes applying a specific test condition during testing of each of the semiconductor devices, wherein the specific test condition is defined by a multiplexer selection function.
- 23. (Original) The method of claim 21, wherein the testing includes blocking some I/O terminals during testing of some semiconductor devices, wherein the blocking is defined by an I/O masking function.
- 24. (Previously Presented) The method of claim 21, wherein the testing includes setting a specific burn-in temperature condition for each of the semiconductor devices.
- 25. (Previously Presented) The method of claim 21, wherein the testing includes performing a single contact test.

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26. (Previously Presented) The method of claim 21, further comprising: a one time bin sorting for the multi-chip package based on the testing result.

27. (Previously Amended) An integrated burn-in test method for testing a multi-chip package, comprising:

providing the multi-chip package formed of multiple kinds of semiconductor devices, the multiple kinds of semiconductor devices include at least two of a non-volatile memory, a SRAM, and a DRAM;

testing the multi-chip package with an integrated burn-in test program adapted to test each of the semiconductor devices, including

performing a single contact test for each of the semiconductor device,
blocking some I/O terminals during testing of some semiconductor devices,
wherein the blocking is defined by an I/O masking function,

setting a specific burn-in temperature condition for each of the semiconductor devices,

conducting a burn-in test for the multi-chip package by applying a specific test condition for each of the semiconductor devices, wherein the specific test condition is defined by a multiplexer selection function; and a one time bin sorting of the multi-chip package based on the testing result.

28. (Previously Presented) The method of claim 1, further comprising: loading the multi-chip package to a chamber of the burn-in equipment.

29. (Previously Presented) The method of claim 14, further comprising: loading the multi chip-package on the burn-in board; and loading the burn-in board into a chamber of the burn-in equipment.

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